

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/566,116	Confirmation No. 3700
Applicant	:	Akihisa Inoue et al.	
371 Filed	:	January 24, 2006	
Art Unit	:	1734	
Examiner	:	Weiping Zhu	
Customer No.	:	00270	
Title	:	SPUTTERING TARGET AND METHOD FOR PRODUCTION THEREOF	

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment timely submitted with a Request for Continued Examination (RCE) in response to a FINAL Office Action dated August 4, 2011. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.